

<b>Notice of References Cited</b>	Application/Control No. 10/776,016	Applicant(s)/Patent Under Reexamination CHANG, DONG-SOO	
	Examiner Heather A. Doty	Art Unit 2813	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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B	US-2002/0001910	01-2002	CHEN et al.	438/305
C	US-			
D	US-			
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H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	S. Wolf and R.N. Tauber, Silicon Processing for the VLSI Era, Volume 1, Second Edition, Lattice Press, 2000, pg. 834.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.